

Title (en)

METHOD FOR MANUFACTURING HEATER FOR HEATING FLAVOR SOURCE

Title (de)

VERFAHREN ZUR HERSTELLUNG EINER HEIZVORRICHTUNG ZUM ERWÄRMEN EINER AROMAQUELLE

Title (fr)

PROCÉDÉ DE FABRICATION D'UN DISPOSITIF DE CHAUFFAGE POUR CHAUFFER UNE SOURCE D'ARÔME

Publication

**EP 4091482 A4 20230920 (EN)**

Application

**EP 20914321 A 20200114**

Priority

JP 2020000852 W 20200114

Abstract (en)

[origin: EP4091482A1] Provided is a method for manufacturing a heater for heating a flavor source, in which a heat generating resistor layer is formed on a main surface, a rear surface, and one side surface. The method includes the steps of forming a heat generating resistor layer by plating on a surface of a plate-like base material and forming an unplated region in the plate-like base material on which the heat generating resistor layer is formed.

IPC 8 full level

**H05B 3/20** (2006.01); **A24F 40/46** (2020.01); **A24F 40/70** (2020.01); **H05B 3/26** (2006.01)

CPC (source: EP)

**A24F 40/70** (2020.01); **H05B 3/265** (2013.01); **H05B 3/267** (2013.01); **A24F 40/20** (2020.01); **A24F 40/46** (2020.01); **H05B 2203/013** (2013.01);  
**H05B 2203/017** (2013.01)

Citation (search report)

- [XA] CN 110652042 A 20200107 - SHENZHEN MAIKE WEIER TECH CO LTD
- [XAI] CN 109984385 A 20190709 - O NET AUTOMATION TECH SHENZHEN LTD
- [A] CN 109413781 A 20190301 - SHENZHEN SUNLORD ELECTRONICS
- [A] JP S59169090 A 19840922 - HITACHI NETSU KIGU KK
- [A] EP 2882308 A1 20150617 - PHILIP MORRIS PRODUCTS SA [CH]
- See references of WO 2021144836A1

Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO RS SE SI SK SM TR

DOCDB simple family (publication)

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DOCDB simple family (application)

**EP 20914321 A 20200114;** JP 2020000852 W 20200114; JP 2021571072 A 20200114